

DEC 20 2006

Patent

Customer No.: 31561
Application No.: 10/711,512
Docket No. 13622-US-PA**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicants : Lu et al.
Application No. : 10/711,512
Filed : September 23, 2004
For : HDPCVD PROCESS AND METHOD FOR IMPROVING
UNIFORMITY OF FILM THICKNESS
Art Unit : 2813
Examiner : Harrison, Monica D

TRANSMITTAL LETTER

+1-571-273-8300 (Via fax: 1+2+5 pages)

ASSISTANT COMMISSIONER FOR PATENTS
Alexandria, VA 22314

Dear Sir,

Applicants hereby file a request for continued examination (RCE) without paying the issue fee and the publication fee as set forth in the Notice of Allowance mailed on September 20, 2006. Attached hereto please find the documents as follows,

- ☒ Request for Continued Examination in (2) pages;
- ☒ Preliminary Amendment in (5) pages.

Since the RCE is filed prior to payment of the issue fee, a petition to withdraw the above-identified application from issue under 37 CFR 1.313 is not required, and Applicants need not pay the issue fee to avoid abandonment of the application. Thus, please charge the fee in the amount of \$ 790 as calculated in the RCE transmittal to the Deposit Account No.: 50-2620 (Order No.: 13622-US-PA).

If the payment is not fully covered in response thereof, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No.: 50-2620 (Order No.: 13622-US-PA).

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property OfficeDate: Dec. 20, 2006By: Belinda Lee

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